



ELECTRONIC COPY

LG804604055
Report verification at igi.org



May 23, 2026
IGI Report Number **LG804604055**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **OVAL BRILLIANT**
Measurements **16.82 X 11.39 X 6.84 MM**
GRADING RESULTS
Carat Weight **8.05 CARATS**
Color Grade **F**
Clarity Grade **VVS 2**

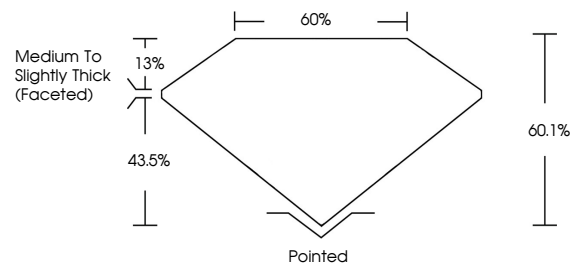
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Color Grade **F**
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ADDITIONAL GRADING INFORMATION
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG804604055**

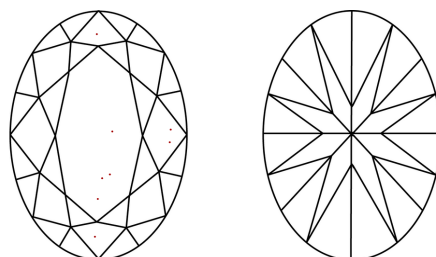
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

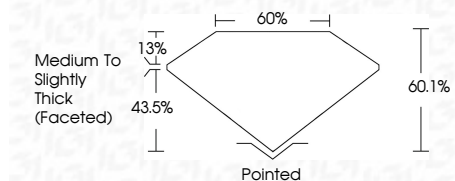
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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OVAL BRILLIANT
16.82 X 11.39 X 6.84 MM
Carat Weight **8.05 CARATS**
Color Grade **F**
Clarity Grade **VVS 2**
Depth **60.1%**
Table **43.5%**
Girdle **Medium to Slightly Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG804604055**
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